



**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshiyuki Ogata et al.

Art Unit: 1712

Application No.: 10/748,190

Examiner: Marc S. Zimmer

Filed: December 31, 2003

Docket: 1608-3 DIV

Confirmation No.: 5536

For: POSITIVE RESIST COMPOSITION AND BASE MATERIAL CARRYING LAYER OF THE POSITIVE RESIST

**COMPOSITION** 

Dated: October 11, 2006

I hereby certify this correspondence is being deposited with United States Postal Service as first class mail, postpaid in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Date: October 11, 2006

Signature Marcy H. Mancuso/ Marcy M. Mancus

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT AND RESPONSE PURSUANT TO 37 C.F.R. §1.111

Sir:

This is in response to the Non-final Office Action mailed July 11, 2006, a reply to which is due by October 11, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.